Notice of References Cited Application/Control No. 10/602,514 Examiner Phillip Nguyen Applicant(s)/Patent Under Reexamination MORRELL, JOHN ALAN Art Unit Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-5,572,538 A	11-1996	Saitoh et al.	372/34
	В	US-2002/0144535 A1	10-2002	Sakata et al.	73/1.03
	С	US-2004/0264519 A1	12-2004	Morrell, John Alan	372/035
	D	US-5,940,420 A	08-1999	Blair et al.	372/35
	E	US-6,498,899 B2	12-2002	Malinoski et al.	392/479
	F	US-6,626,635 B1	09-2003	Prowse et al.	415/1
	G	US-6,457,515	10-2002	Vafai et al.	165/80.4
	Η	US-2004/0247483	12-2004	Uemura et al.	422/080
	- 1	US-6,310,356	10-2001	Yuhara et al.	250/574
	٦	US-5,970,729	10-1999	Yamamoto et al.	62/178
	К	US-4,415,847	11-1983	Galloway, James H.	320/150
	L	US-6,570,900	05-2003	Furumoto et al.	372/54
	М	US-6,246,710	06-2001	Furumoto et al.	372/54

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	Ν	JP 2005079195 A	03-2005	Japan	KAWASHIMA et al.	H01S 03/042
	0					
	Р					
	Q					
	R					
	s					
	Т	·				

NON-PATENT DOCUMENTS

$\overline{}$	r -	
*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	٧	
	w	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.